Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination
10/642,343	GIESSLER ET AL.
Examiner	Art Unit
Sara Addisu	3722

	SEARCHED				
Class	Subclass	Date	Examiner		
407	53,54,61	11/16/2005	SA		
408	230,227	11/16/2005	SA		
above	UPDATED	6/6/2006	SA		

INT	INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner	

SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
Dan Howell	6/7/2005	SA
Inventor name search	11/16/2005	SA
Consulted Hwei Su Payer about restricting claims 11-14 in class 76/108.6. Agreed	6/7/2005	SA
Consulted H. Payer about treverse to restricting claims 11-14. FIB (focused Ion Beam) is known as an alternative to grinding	11/17/2005	SA